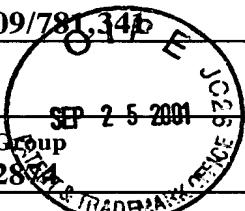


<b>Form PTO-1449</b>		<b>U.S. Department of Commerce Patent and Trademark Office</b>							<b>Atty. Docket No.</b> <b>0980/62251-C</b>	<b>Serial No.</b> <b>09/781,345</b>
		<b>INFORMATION DISCLOSURE CITATION BY APPLICANT</b>							<b>Applicant</b> <b>Shih-Yuan Wang</b>	
									<b>Filing Date</b> <b>February 12, 2001</b>	

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Atty. Docket No.  
0980/62251-CSerial No.  
09/781,344 FApplicant  
Shih-Yuan Wang

SEP 25 2001

Filing Date  
February 12, 2001Group  
2874

TRADEMARK OFFICE

**U.S. PATENT DOCUMENTS**

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GW	AH	Dutton, <i>Understanding Optical Communications</i> (Prentice-Hall 1998), Contents and pages 42-45
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GW	AK	<a href="http://www.blazephotonics.com/pages/techn.htm">http://www.blazephotonics.com/pages/techn.htm</a> - dated 03/30/01
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GW	AM	U.S. Application Serial No. 09/781,344, filed 02/12/01
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Atty. Docket No.  
**0980/62251-C**Serial No.  
**09/781,345**Applicant  
**Shih-Yuan Wang**Filing Date  
**February 12, 2001**Group  
**287**

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<b>INFORMATION DISCLOSURE CITATION BY APPLICANT</b> (Use several sheets if necessary)								Applicant <b>Shih-Yuan Wang</b>		
								Filing Date <b>February 12, 2001</b>	Group <b>2874</b>	
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	AI									
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